

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Zhang et al.
Title: Fabrication of Solid-State Nanostructures
Including sub-50 nm Solid-State Nanostructures
Based on Nanolithography and Chemical
Etching
Appl. No.: 10/725,939
Filing Date: 12/3/2003
Examiner: Culbert
Art Unit: 1762
Conf. No.: 4466

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The Applicants respond to the Non-Final Office Action dated December 15, 2006 and petition for a three month extension of time.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this document.

Remarks/Arguments begin on page 8 of this document.

Please amend the application as follows: